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By: Stina L. McNeill

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE -
EXAMINING GROUP 1753**

PATENT

Attorney Docket No.: A8067/T51700
AMAT No.: 008067/DSM/HDP/CVD/JW
TTC No.: 016301-051700US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hemant P. Mungekar et al.

Application No.: 10/660,813

Filed: September 12, 2003

For: REACTIVE ION ETCHING FOR
SEMICONDUCTOR DEVICE
FEATURE TOPOGRAPHY
MODIFICATION

Customer No.: 57385

Confirmation No. 7055

Examiner: McDonald, Rodney Glenn

Technology Center/Art Unit: 1753

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE EXAMINING
GROUP 1753**

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed February 14, 2006 on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 7 of this paper.